

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)	Confirmation No.: 3788
Shinji MAEKAWA et al.	)	
Serial No.: 10/575,492	)	Examiner: Stanetta D. Isaac
Filed: April 12, 2006	)	Group Art Unit: 2812
For: METHOD FOR FORMING WIRING, METHOD FOR	)	Date: June 30, 2010
MANUFACTURING THIN FILM TRANSISTOR	)	
AND DROPLET DISCHARGING METHOD	)	

**AMENDMENT AND RESPONSE**

**MAIL STOP - AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action mailed March 30, 2010, response to which is timely due June 30, 2010, the present response is deemed to be timely filed. Entry of this amendment and response is respectfully requested.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 12 of this paper.